

<b>Notice of References Cited</b>	Application/Control No. 10/577,441		Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner VAN N. CHOW		Art Unit 2627	Page 1 of 1

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*	C	US-2004/0105374	06-2004	Ogasawara et al.	369/112.02
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